PATENT NUMBER and ISSUE DATE

U.S. UTILITY Patent Application

APPL NUI 10038066		CLASS	SUBCLASS	GAU 2812	,	Jalen	INER N	lik	ins
F*APPLICA Daniel;	NTS: Chen L	iang-Yuh	; Hsu Wei-Yun	g; Dubo	oust Ala	in; Morad R	atson; C	arl	
THIS APPL AND CLAIM AND CLAIM	IING DATA VERIFIEI N CLAIMS BENEFIT IS BENEFIT OF 60/2: IS BENEFIT OF 60/3:	OF 60/27 86,107 04 26,263 10	4/24/2001	001					
FOREIGN	I APPLICATIONS VE	RIFIED:							
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Foreign priority 35 USC 119 co Verified and Ac		□ yes	s □ no s □ no			RNEY DOCK 5699/CMP/0		K	
TITLE : Plan	arization of substrates	s using el	lectrochemical	mechar		lishing EPT. OF COMM <i>IPA</i>	T.& TM-PTO	436L(Re	v. 12-94)
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		Primary Examiner		· · · · · · · · · · · · · · · · · · ·						
TERMINAL		PREPARED FOR ISSUE	Application Examiner							
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